

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLN. OF: ITO

FILED: AUGUST 27, 2001

FOR: METHOD FOR FORMING A SILICIDE LAYER

DOCKET: NEC 2360

BOX PATENT APPLICATION

The Commissioner of Patents & Trademarks

Washington, D.C. 20231

1c979 U.S. PTO
09/940247
08/27/01

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

In connection with the above-entitled matter, Applicant hereby attaches U.S. Patent Office Form PTOL-1449, including copies of the prior art references listed therein. Japanese references Nos. 2000-31091, 2559669 and 2565665 are discussed in the specification. The claims in the present application are believed to be patentably distinguished over these references.

This information disclosure statement is being made pursuant to the duty of disclosure imposed by law and formulated in 37 CFR 1.56(A). No representation is made that the information thus disclosed in fact constitute prior art or that it is the closest prior art, inasmuch as 37 CFR 1.56(A) relies on a materiality concept which depends on subjectivity.

In the event there are any fee deficiencies or additional fees are payable, please charge them (or credit any overpayment) to our Deposit Account No. 08-1391.

Respectfully submitted,

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